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					Application Number	Not Assigned		
	EINFO	ORMATI	ON DIS	CLOSURE	Filing Date	31 October 2003		
\o,	ŚŤA	TEMENT	BY AP	PLICANT	First Named Inventor	BINTORO, Jemmy		
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FEB	17 000 5	3			Examiner Name	Not Assigned		
E.	She	1	of	4	Attorney Docket Number	GTRC132		

ALEX D				U.S. PATE	NT DOCUMENTS	
Examiner Initials	Cite No.1	U.S. Patent Docume Number Kind C	1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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				FOREIGN	PATENT DOCI	JMENTS		
		Fe	oreign Patent Docur	nent			Pages, Columns, Lines,	
Examiner Initials	Cite No.	Country Code ³	Number 4	Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	ぜ
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Examiner	DINBUAN	Date	02-64-06
Signature	JONO VA	Considered	03-01-06

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kind Codes of U.S. Patent Documents at www.uspto.gov. Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO	Complete If Known				
	Application Number	Not Assigned			
IP INFORMATION DISCLOSURE	Filing Date	31 October 2003			
STEREMENT BY APPLICANT	First Named Inventor	BINTORO, Jemmy			
2 7 2004 (Use as many sheets as necessary)	Group Art Unit	Not Assigned			
1 2 7 200 y	Examiner Name	Not Assigned			
Sheet 2 of 4	Attorney Docket Number	GTRC132			

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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite, No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number)s), publisher, city and/or county where published.	T ²
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Examiner Signature	DONOVAN	Date Considered	03-64-06
Signature		Considered	

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Application Number N	lot Assigned
Filing Date 3	1 October 2003
First Named Inventor B	INTORO, Jemmy
Group Art Unit N	lot Assigned
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Attorney Docket Number G	TRC132
	Filing Date 3 First Named Inventor B Group Art Unit N Examiner Name N

VER	- Alexander	NON PATENT LITERATURE DOCUMENTS							
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number)s), publisher, city and/or county where published.	T ²						
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Examiner	D. CALCA A	Date	115-04-06
Signature	DONOVAN	Considered	03-09-06

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Substi	tute for	form 1449B	/PTO			Complete If Known					
						Application Num	ber	Not	Assigned		
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40		JEMMY S	SUTANT	TO BIN	TORO et al.,	Mechanical and Mag					
Lo	JEMMY SUTANTO BINTORO et al., Fabrication of a Bistable Electromagnetic Actuator for Microvalve										
LD		JEMMY S Integrated				A Bistable Electroma	agnetic Actuate	ed Mic	rovalve with		
Lp	JEMMY SUTANTO BINTORO et al., Fabricated on a Single Wafer, Implement					, A Structure of Bistable Electromagnetic Actuated Microvalve lenting the SLA and PDMS Technique					
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